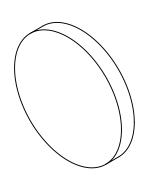
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- 3. COATING (APPLY ACROSS COATING APERTURE)
 - \$1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 408 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 390nm @ 0° AOI T(abs): =50% FOR 400±4nm @ 0° AOI

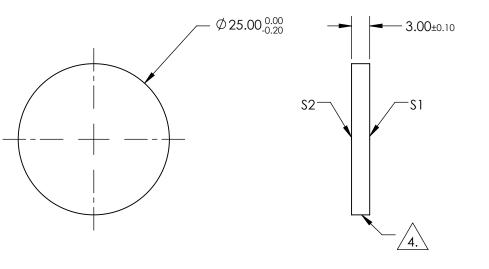
S2:SINGLE LAYER MgF2

4. FINE GRIND SURFACE

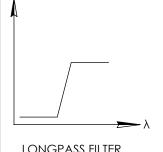
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT







6



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LONGINGSTIELER			_			Edmund Optics [®]
REV A	S1	\$2				
SHAPE	PLANO	PLANO		1		Ø25mm, 400nm, HIGH PERFORMANCE
SURFACE QUALITY	40-20	40-20	THIRD ANGLE		TITLE	LONGPASS FILTER
CLEAR APERTURE	>80%	>80%		1		
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN	mm	DWG NO	62981 SHEET 1 OF 1

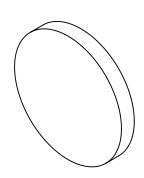
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- 3. COATING (APPLY ACROSS COATING APERTURE)
 - \$1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 458 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 440nm @ 0° AOI T(abs): =50% FOR 450±4.5nm @ 0° AOI

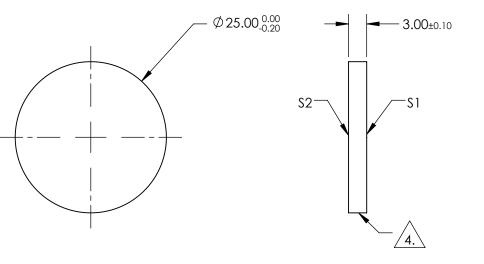
S2:SINGLE LAYER MgF2

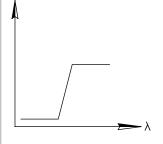
4. FINE GRIND SURFACE

- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT









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LONGPASS FILTER						Edmund Optic	کدھ
REV A	S1	S2					5
SHAPE	PLANO	PLANO		1		Ø25mm, 450nm, HIGH PERFORMAN	CF
SURFACE QUALITY	40-20	40-20			TITLE	LONGPASS FILTER	
CLEAR APERTURE	>80%	>80%					
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN	mm	DWG NO	62982	SHEET 1 OF 1

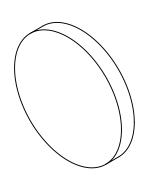
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- 3. COATING (APPLY ACROSS COATING APERTURE)
 - \$1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 508 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 490nm @ 0° AOI T(abs): =50% FOR 500±5nm @ 0° AOI

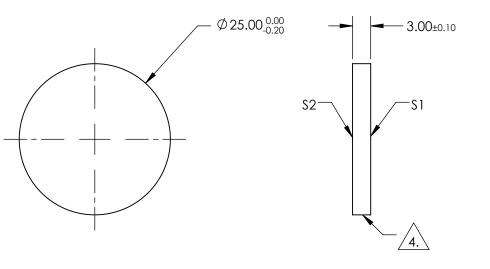
S2:SINGLE LAYER MgF2

4. FINE GRIND SURFACE

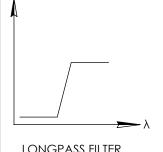
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT







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LONGINGSTIELER			_			Edmund Optic	C ®
REV A	S1	S2					, Э
SHAPE	PLANO	PLANO				Ø25mm, 500nm, HIGH PERFORMANC	∩F
SURFACE QUALITY	40-20	40-20	THIRD ANGLE . PROJECTION	THIRD ANGLE		LONGPASS FILTER	
CLEAR APERTURE	>80%	>80%					SHEET
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN	mm	DWG NO	62983	1 OF 1

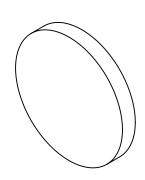
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- 3. COATING (APPLY ACROSS COATING APERTURE)
 - \$1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 560 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 539nm @ 0° AOI T(abs): =50% FOR 550±5.5nm @ 0° AOI

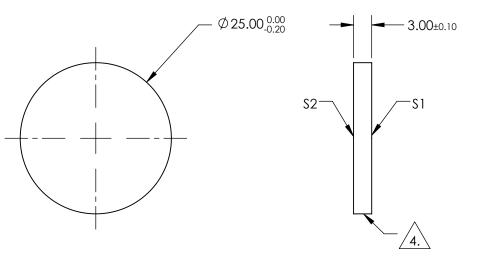
S2:SINGLE LAYER MgF2

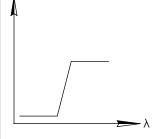
4. FINE GRIND SURFACE

- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT









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LONGPASS FILTER			_			Edmund Optic	C ®
REV A	S1	S2					5
SHAPE	PLANO	PLANO				Ø25mm, 550nm, HIGH PERFORMAN	CF
SURFACE QUALITY	40-20	40-20	THIRD ANGLE		TITLE	LONGPASS FILTER	
CLEAR APERTURE	>80%	>80%		 			
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN	mm	DWG NO	62984	SHEET 1 OF 1

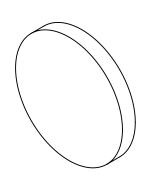
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- 3. COATING (APPLY ACROSS COATING APERTURE)
 - \$1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 610 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 588nm @ 0° AOI T(abs): =50% FOR 600±6nm @ 0° AOI

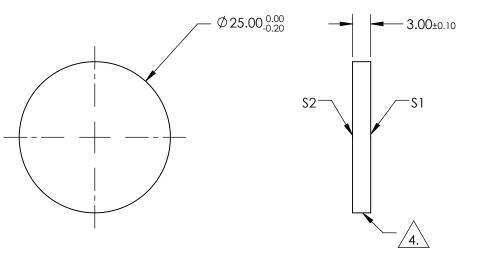
S2:SINGLE LAYER MgF2

4. FINE GRIND SURFACE

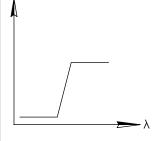
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT







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LONGPASS FILTER

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LONGINGSTIELER			_			Edmund Optic	C ®
REV A	S1	S2					5
SHAPE	PLANO	PLANO				Ø25mm, 600nm, HIGH PERFORMAN	CF
SURFACE QUALITY	40-20	40-20			TITLE	LONGPASS FILTER	
CLEAR APERTURE	>80%	>80%		1			SHEET
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN	mm	DWG NO	62985	1 OF 1

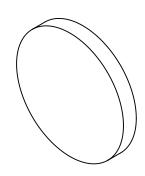
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- 3. COATING (APPLY ACROSS COATING APERTURE)
 - \$1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 660 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 637nm @ 0° AOI T(abs): =50% FOR 650±6.5nm @ 0° AOI

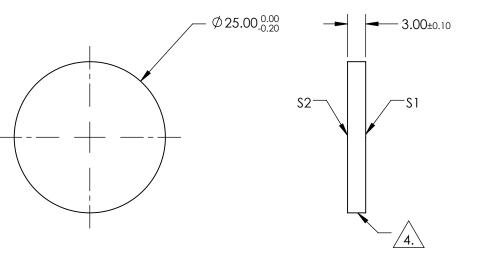
S2:SINGLE LAYER MgF2

4. FINE GRIND SURFACE

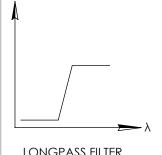
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT







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LONGINGSTILLER					[©] Edmund Optics [®]
REV A	S1	S2			
SHAPE	PLANO	PLANO			Ø25mm, 650nm, HIGH PERFORMANCE
SURFACE QUALITY	40-20	40-20		TITLE	LONGPASS FILTER
CLEAR APERTURE	>80%	>80%			SHEET
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN mm	DWG NO	62986 SHEET 1 OF 1

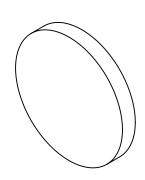
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- 3. COATING (APPLY ACROSS COATING APERTURE)
 - \$1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 710 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 686nm @ 0° AOI T(abs): =50% FOR 700±7nm @ 0° AOI

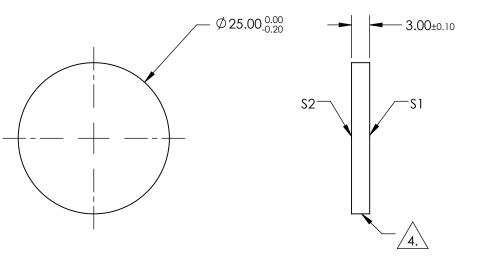
S2:SINGLE LAYER MgF2

4. FINE GRIND SURFACE

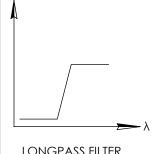
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT







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LONGINGSTILLER					Edmund Optics [®]
REV A	S1	S2			
SHAPE	PLANO	PLANO			Ø25mm, 700nm, HIGH PERFORMANCE
SURFACE QUALITY	40-20	40-20		TITLE	LONGPASS FILTER
CLEAR APERTURE	>80%	>80%			SHEET
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN mm	DWG NO	62987 SHEET

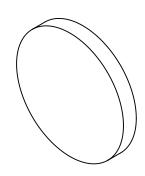
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- 3. COATING (APPLY ACROSS COATING APERTURE)
 - \$1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 765 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 735nm @ 0° AOI T(abs): =50% FOR 750±7.5nm @ 0° AOI

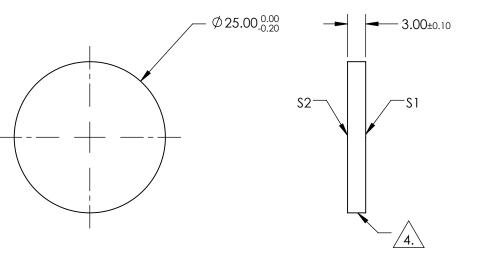
S2:SINGLE LAYER MgF2

4. FINE GRIND SURFACE

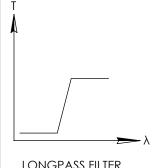
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT







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LONGINGSTIELER					Edmund Optic	C ®
REV A	S1	\$2				5
SHAPE	PLANO	PLANO			Ø25mm, 750nm, HIGH PERFORMAN	CF
SURFACE QUALITY	40-20	40-20	THIRD ANGLE	TITLE	LONGPASS FILTER	
CLEAR APERTURE	>80%	>80%				
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN mm	DWG NO	66234	Sheet 1 Of 1

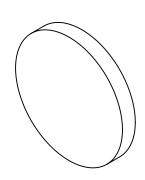
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- 3. COATING (APPLY ACROSS COATING APERTURE)
 - \$1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 815 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 785nm @ 0° AOI T(abs): =50% FOR 800±8nm @ 0° AOI

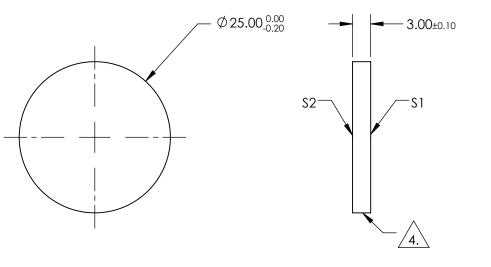
S2:SINGLE LAYER MgF2

4. FINE GRIND SURFACE

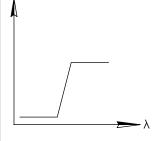
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT







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LONGPASS FILTER

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LONGINGSTIELER			_			Edmund Optics	C ®
REV A	S1	S2					Э
SHAPE	PLANO	PLANO				Ø25mm, 800nm, HIGH PERFORMANC	ÌF
SURFACE QUALITY	40-20	40-20	THIRD ANGLE . PROJECTION			LONGPASS FILTER	
CLEAR APERTURE	>80%	>80%		1			SHEET
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN	mm	DWG NO	66235	1 OF 1

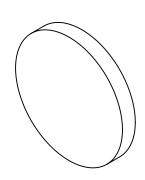
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- 3. COATING (APPLY ACROSS COATING APERTURE)
 - \$1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 865 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 835nm @ 0° AOI T(abs): =50% FOR 850±8.5nm @ 0° AOI

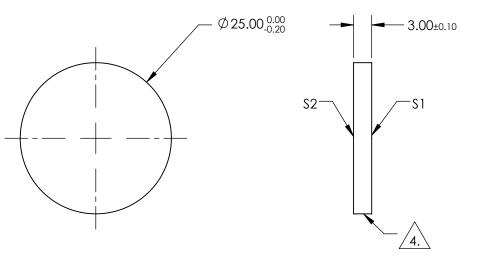
S2:SINGLE LAYER MgF2

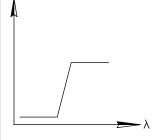
4. FINE GRIND SURFACE

- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT









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LONGPASS FILTER						Edmund Optic	с®
REV A	S1	S2					5
SHAPE	PLANO	PLANO				Ø25mm, 850nm, HIGH PERFORMAN	ICF
SURFACE QUALITY	40-20	40-20	THIRD ANGLE . PROJECTION	THIRD ANGLE		LONGPASS FILTER	
CLEAR APERTURE	>80%	>80%					
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN	mm	DWG NO	66236	SHEET 1 OF 1

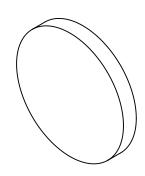
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- 3. COATING (APPLY ACROSS COATING APERTURE)
 - \$1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 915 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 880nm @ 0° AOI T(abs): =50% FOR 900±9nm @ 0° AOI

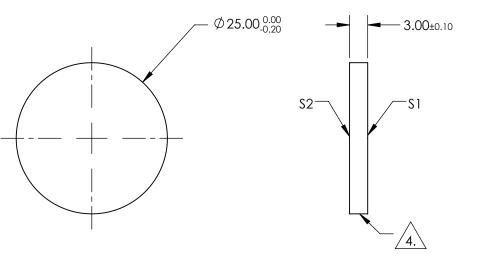
S2:SINGLE LAYER MgF2

4. FINE GRIND SURFACE

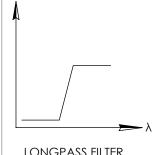
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT







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LONGINGOHEIEK			_		Edmund Optic	C ®
REV A	S1	S2				,3
SHAPE	PLANO	PLANO			Ø25mm, 900nm, HIGH PERFORMANO	CF
SURFACE QUALITY	40-20	40-20	THIRD ANGLE	TITLE	LONGPASS FILTER	
CLEAR APERTURE	>80%	>80%				CULLET
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN mm	DWG NO	66237	Sheet 1 Of 1

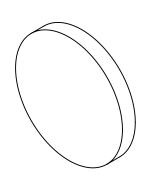
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- 3. COATING (APPLY ACROSS COATING APERTURE)
 - \$1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 965 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 930nm @ 0° AOI T(abs): =50% FOR 950±9.5nm @ 0° AOI

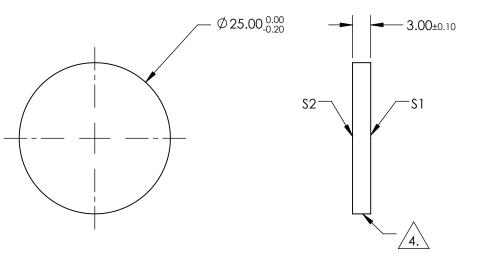
S2:SINGLE LAYER MgF2

4. FINE GRIND SURFACE

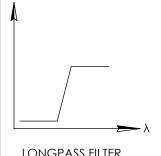
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT







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			_		Edmund Optic	C ®
REV A	S1	\$2				5
SHAPE	PLANO	PLANO			Ø25mm, 950nm, HIGH PERFORMANC	∩F
SURFACE QUALITY	40-20	40-20	THIRD ANGLE	TITLE	LONGPASS FILTER	
CLEAR APERTURE	>80%	>80%				
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN mm	DWG NO	66238	Sheet 1 Of 1

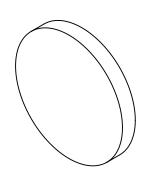
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- 3. COATING (APPLY ACROSS COATING APERTURE)
 - \$1: HARD DIELECTRIC SPUTTERED
 T(avg): ≥91% FROM 1020 1650nm @ 0° AOI
 T(avg): ≤0.01% FROM 200 980nm @ 0° AOI
 T(abs): =50% FOR 1000±10nm @ 0° AOI

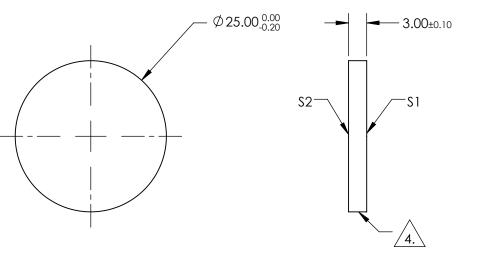
S2:SINGLE LAYER MgF2

4. FINE GRIND SURFACE

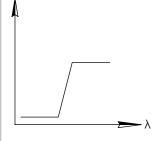
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT







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LONGPASS FILTER

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LONGINGSTILLER			_			Edmund Optic	C ®
REV A	S1	S2					<i>,</i> 3
SHAPE	PLANO	PLANO				Ø25mm, 1000nm, HIGH PERFORMAN	ICF
SURFACE QUALITY	40-20	40-20	THIRD ANGLE		TITLE	LONGPASS FILTER	
CLEAR APERTURE	>80%	>80%		1			SHEET
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN	mm	DWG NO	66239	1 OF 1

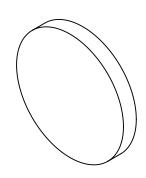
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- 3. COATING (APPLY ACROSS COATING APERTURE)
 - S1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 1070 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 1030nm @ 0° AOI T(abs): =50% FOR 1050±10.5nm @ 0° AOI

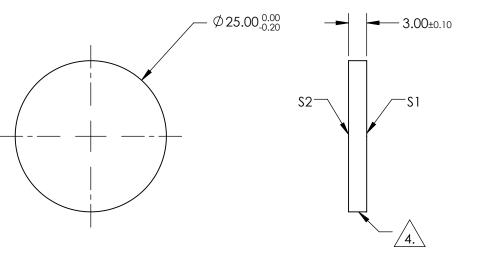
S2:SINGLE LAYER MgF2

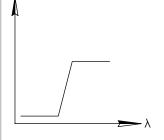
4. FINE GRIND SURFACE

- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT









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LONGPASS FILTER						Edmund Optics [®]
REV A	S1	S2				
SHAPE	PLANO	PLANO		1		Ø25mm, 1050nm, HIGH PERFORMANCE
SURFACE QUALITY	40-20	40-20	THIRD ANGLE		TITLE	LONGPASS FILTER
CLEAR APERTURE	>80%	>80%]r	I		
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN	mm	DWG NO	66240 SHEET 1 OF 1

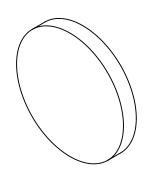
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- 3. COATING (APPLY ACROSS COATING APERTURE)
 - \$1: HARD DIELECTRIC SPUTTERED
 T(avg): ≥91% FROM 1120 1650nm @ 0° AOI
 T(avg): ≤0.01% FROM 200 1080nm @ 0° AOI
 T(abs): =50% FOR 1100±11nm @ 0° AOI

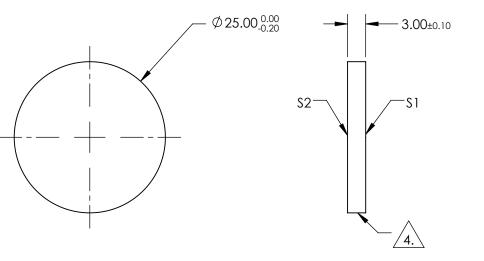
S2:SINGLE LAYER MgF2

4. FINE GRIND SURFACE

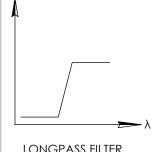
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT







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LONGINGSTILLER						Edmund Optic	C ®
REV A	S1	S2					, Э
SHAPE	PLANO	PLANO				Ø25mm, 1100nm, HIGH PERFORMAN	CF
SURFACE QUALITY	40-20	40-20	THIRD ANGLE . PROJECTION	$\bigcirc \bigcirc \bigcirc$	TITLE	LONGPASS FILTER	
CLEAR APERTURE	>80%	>80%					SHEET
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN	mm	DWG NO	66241	1 OF 1

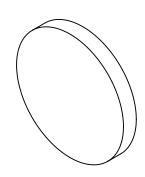
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- 3. COATING (APPLY ACROSS COATING APERTURE)
 - \$1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 433 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 415nm @ 0° AOI T(abs): =50% FOR 425±4.25nm @ 0° AOI

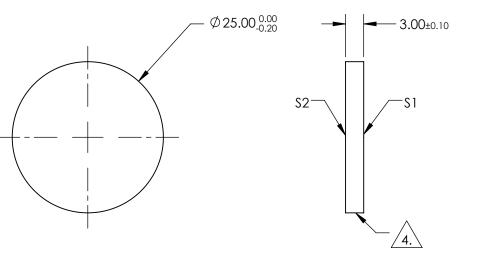
S2:SINGLE LAYER MgF2

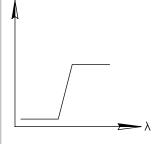
4. FINE GRIND SURFACE

- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT









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LONGPASS FILTER						Edmund Optics	C ®
REV A	S1	S2					3
SHAPE	PLANO	PLANO				Ø25mm, 425nm, HIGH PERFORMANC	~F
SURFACE QUALITY	40-20	40-20	THIRD ANGLE		TITLE	LONGPASS FILTER	
CLEAR APERTURE	>80%	>80%					CULLET
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN	mm	DWG NO	84742	Sheet 1 Of 1

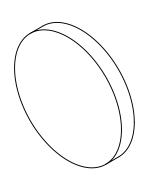
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- 3. COATING (APPLY ACROSS COATING APERTURE)
 - \$1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 483 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 465nm @ 0° AOI T(abs): =50% FOR 475±4.75nm @ 0° AOI

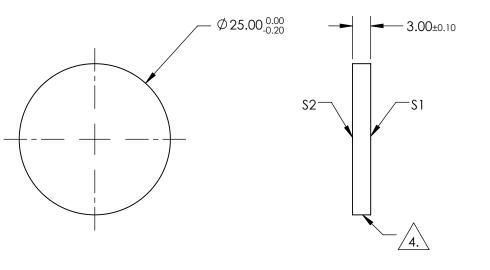
S2:SINGLE LAYER MgF2

4. FINE GRIND SURFACE

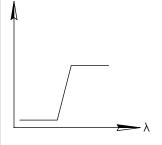
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT







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LONGPASS FILTER

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LONGINGOTIETER			_			Edmund Optics [®]	
REV A	S1	S2					
SHAPE	PLANO	PLANO				Ø25mm, 475nm, HIGH PERFORMANCE	
SURFACE QUALITY	40-20	40-20	THIRD ANGLE	$\bigcirc \bigcirc$	TITLE	LONGPASS FILTER	
CLEAR APERTURE	>80%	>80%					
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN	mm	DWG NO	84743 SHEE 1 OF	

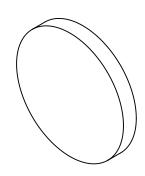
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- 3. COATING (APPLY ACROSS COATING APERTURE)
 - \$1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 534 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 515nm @ 0° AOI T(abs): =50% FOR 525±5.25nm @ 0° AOI

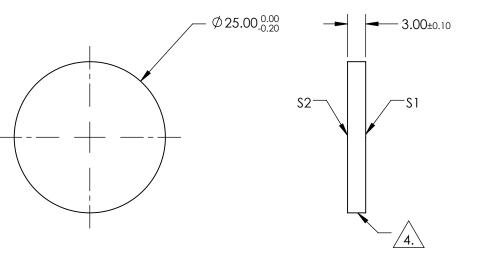
S2:SINGLE LAYER MgF2

4. FINE GRIND SURFACE

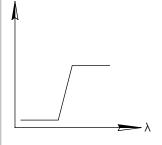
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT







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LONGPASS FILTER

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LONGITIGGT			_			Edmund Optics	C ®
REV A	S1	S2					5
SHAPE	PLANO	PLANO				Ø25mm, 525nm, HIGH PERFORMANC	F
SURFACE QUALITY	40-20	40-20			TITLE	LONGPASS FILTER	
CLEAR APERTURE	>80%	>80%		1			CUEET
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN	mm	DWG NO	84744	Sheet 1 Of 1

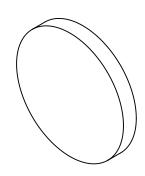
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- 3. COATING (APPLY ACROSS COATING APERTURE)
 - \$1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 585 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 564nm @ 0° AOI T(abs): =50% FOR 575±5.75nm @ 0° AOI

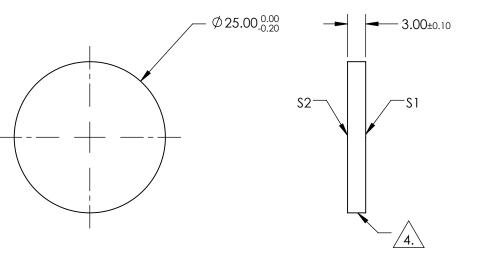
S2:SINGLE LAYER MgF2

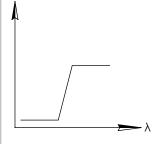
4. FINE GRIND SURFACE

- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT









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LONGPASS FILTER			_			Edmund Optics [®]
REV A	S1	S2				
SHAPE	PLANO	PLANO				Ø25mm, 575nm, HIGH PERFORMANCE
SURFACE QUALITY	40-20	40-20	THIRD ANGLE		TITLE	LONGPASS FILTER
CLEAR APERTURE	>80%	>80%				
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN mi	nm	DWG NO	84745 SHEET 1 OF 1

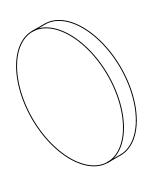
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- 3. COATING (APPLY ACROSS COATING APERTURE)
 - \$1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 635 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 613nm @ 0° AOI T(abs): =50% FOR 625±6.25nm @ 0° AOI

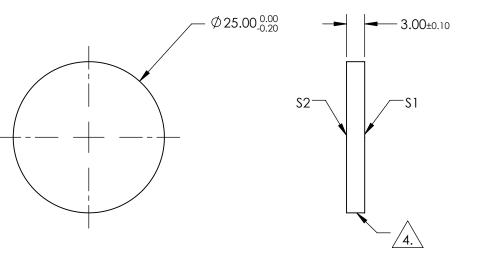
S2:SINGLE LAYER MgF2

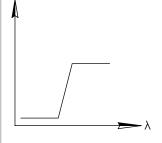
4. FINE GRIND SURFACE

- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT









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LONGPASS FILTER			_			Edmund Optic	C ®
REV A	S1	S2					3
SHAPE	PLANO	PLANO		1		Ø25mm, 625nm, HIGH PERFORMANC	^F
SURFACE QUALITY	40-20	40-20	THIRD ANGLE		TITLE	LONGPASS FILTER	
CLEAR APERTURE	>80%	>80%	'	1			CLIEFT
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN	mm	DWG NO	84746	Sheet 1 Of 1

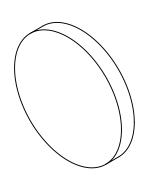
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- 3. COATING (APPLY ACROSS COATING APERTURE)
 - \$1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 685 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 662nm @ 0° AOI T(abs): =50% FOR 675±6.75nm @ 0° AOI

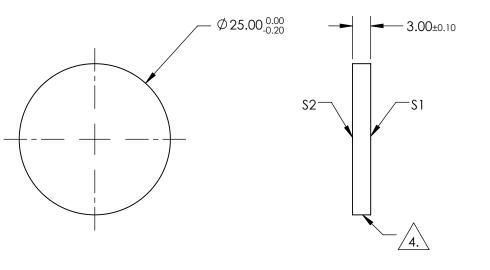
S2:SINGLE LAYER MgF2

4. FINE GRIND SURFACE

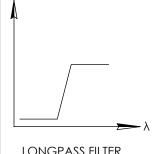
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT







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LONGINGOTIETER						Edmund Optics	R
REV A	S1	S2					
SHAPE	PLANO	PLANO				Ø25mm, 675nm, HIGH PERFORMANCE	:
SURFACE QUALITY	40-20	40-20			TITLE	LONGPASS FILTER	
CLEAR APERTURE	>80%	>80%		1			
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN	mm	DWG NO	84747	SHEET I OF 1

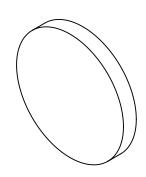
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- 3. COATING (APPLY ACROSS COATING APERTURE)
 - \$1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 735 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 705nm @ 0° AOI T(abs): =50% FOR 725±7.25nm @ 0° AOI

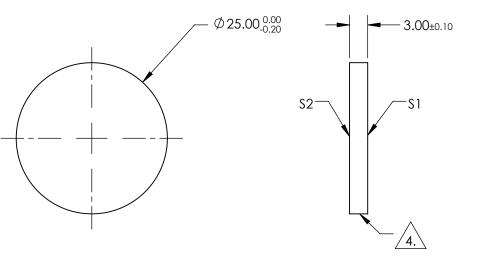
S2:SINGLE LAYER MgF2

4. FINE GRIND SURFACE

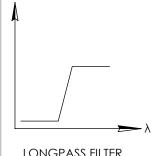
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT







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LONGINGOTIETER						Edmund Optics	R
REV A	S1	S2)
SHAPE	PLANO	PLANO				Ø25mm, 725nm, HIGH PERFORMANCE	=
SURFACE QUALITY	40-20	40-20			TITLE	LONGPASS FILTER	
CLEAR APERTURE	>80%	>80%		1			
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN	mm	DWG NO	86068	Sheet 1 Of 1

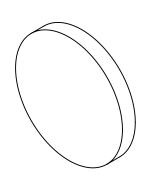
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- 3. COATING (APPLY ACROSS COATING APERTURE)
 - \$1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 790 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 760nm @ 0° AOI T(abs): =50% FOR 775±7.75nm @ 0° AOI

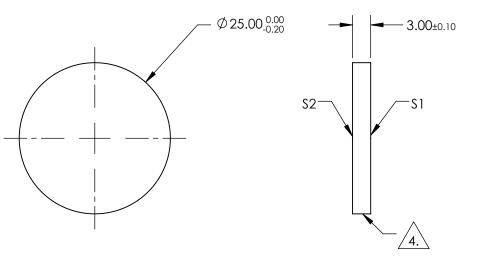
S2:SINGLE LAYER MgF2

4. FINE GRIND SURFACE

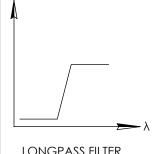
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT







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LONGINGSTIELER						Edmund Optics [®]
REV A	S1	\$2				
SHAPE	PLANO	PLANO		1		Ø25mm, 775nm, HIGH PERFORMANCE
SURFACE QUALITY	40-20	40-20	THIRD ANGLE PROJECTION	$\bigcirc \bigcirc \bigcirc \$	TITLE	LONGPASS FILTER
CLEAR APERTURE	>80%	>80%		I		
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN	mm	DWG NO	86069 SHEET 1 OF 1

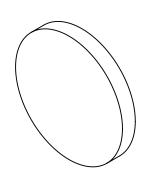
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- 3. COATING (APPLY ACROSS COATING APERTURE)
 - \$1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 840 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 805nm @ 0° AOI T(abs): =50% FOR 825±8.25nm @ 0° AOI

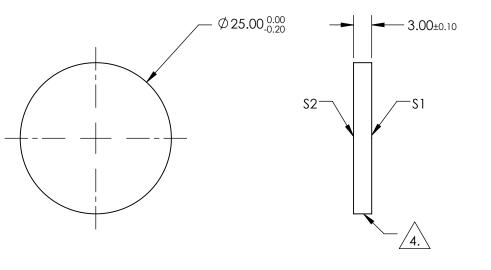
S2:SINGLE LAYER MgF2

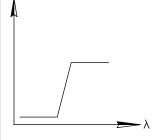
4. FINE GRIND SURFACE

- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT









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LONGPASS FILTER			_			Edmund Optic	C ®
REV A	S1	S2					5
SHAPE	PLANO	PLANO				Ø25mm, 825nm, HIGH PERFORMANC	C F
SURFACE QUALITY	40-20	40-20	THIRD ANGLE		TITLE	LONGPASS FILTER	
CLEAR APERTURE	>80%	>80%					CLIEFT
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN	mm	DWG NO	86070	Sheet 1 Of 1

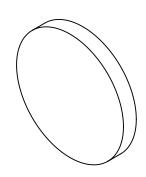
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- 3. COATING (APPLY ACROSS COATING APERTURE)
 - \$1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 890 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 860nm @ 0° AOI T(abs): =50% FOR 875±8.75nm @ 0° AOI

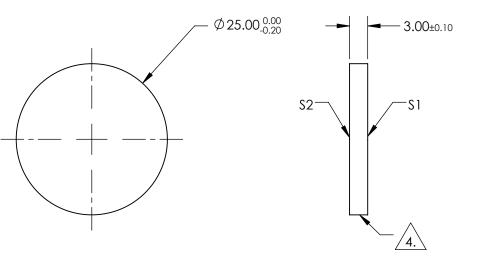
S2:SINGLE LAYER MgF2

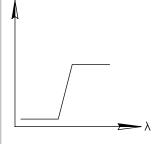
4. FINE GRIND SURFACE

- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT









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LONGPASS FILTER						Edmund Optics [®]
REV A	S1	S2				
SHAPE	PLANO	PLANO				Ø25mm, 875nm, HIGH PERFORMANCE
SURFACE QUALITY	40-20	40-20				LONGPASS FILTER
CLEAR APERTURE	>80%	>80%				
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN	mm	DWG NO	86071 SHEET 1 OF 1

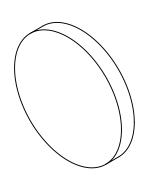
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- 3. COATING (APPLY ACROSS COATING APERTURE)
 - \$1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 940 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 905nm @ 0° AOI T(abs): =50% FOR 925±9.25nm @ 0° AOI

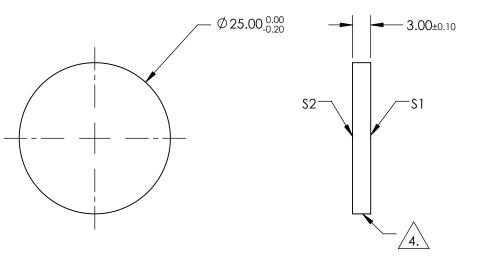
S2:SINGLE LAYER MgF2

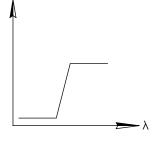
4. FINE GRIND SURFACE

- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT









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LONGPASS FILTER			_			Edmund Optic	C ®
REV A	S1	S2					5
SHAPE	PLANO	PLANO				Ø25mm, 925nm, HIGH PERFORMAN	CF
SURFACE QUALITY	40-20	40-20			- TITLE	LONGPASS FILTER	
CLEAR APERTURE	>80%	>80%					
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN	mm	DWG NO	86072	SHEET 1 OF 1

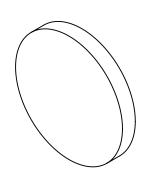
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- 3. COATING (APPLY ACROSS COATING APERTURE)
 - \$1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 990 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 955nm @ 0° AOI T(abs): =50% FOR 975±9.75nm @ 0° AOI

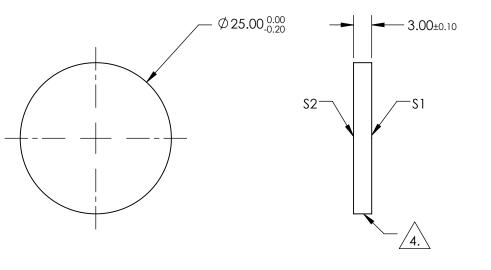
S2:SINGLE LAYER MgF2

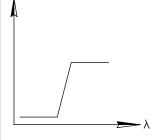
4. FINE GRIND SURFACE

- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT









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LONGPASS FILTER			_		Edmund Optics [®]	
REV A	S1	S2				
SHAPE	PLANO	PLANO			Ø25mm, 975nm, HIGH PERFORMANCE	
SURFACE QUALITY	40-20	40-20	THIRD ANGLE	TITLE	LONGPASS FILTER	
CLEAR APERTURE	>80%	>80%				
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN mm	DWG NO	86073 SHEET 1 OF 1	

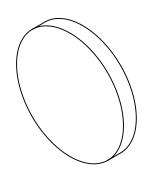
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- 3. COATING (APPLY ACROSS COATING APERTURE)
 - S1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 1045 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 1005nm @ 0° AOI T(abs): =50% FOR 1025±10.25nm @ 0° AOI

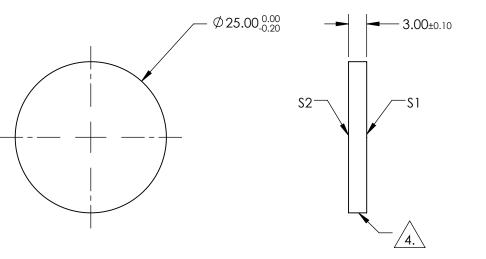
S2:SINGLE LAYER MgF2

4. FINE GRIND SURFACE

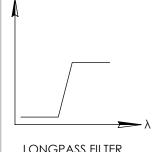
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT







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LONGITIGGT			_			Edmund Optics [®]	
REV A	S1	\$2					
SHAPE	PLANO	PLANO				Ø25mm, 1025nm, HIGH PERFORMANCE	
SURFACE QUALITY	40-20	40-20	THIRD ANGLE		TITLE	LONGPASS FILTER	
CLEAR APERTURE	>80%	>80%	'				
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN	mm	DWG NO	86074 SHEET 1 OF 1	

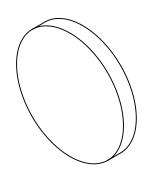
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- 3. COATING (APPLY ACROSS COATING APERTURE)
 - S1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 1095 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 1055nm @ 0° AOI T(abs): =50% FOR 1075±10.75nm @ 0° AOI

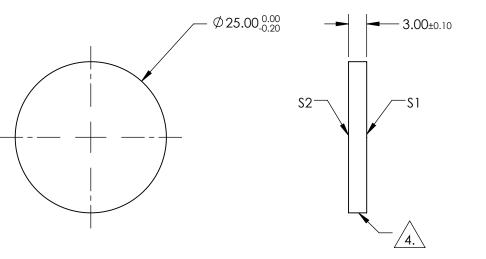
S2:SINGLE LAYER MgF2

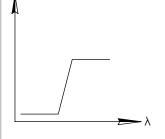
4. FINE GRIND SURFACE

- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT









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LONGPASS FILTER			_			Edmund Optic	с®
REV A	S1	S2					5
SHAPE	PLANO	PLANO				Ø25mm, 1075nm, HIGH PERFORMAN	JCF
SURFACE QUALITY	40-20	40-20	THIRD ANGLE			LONGPASS FILTER	
CLEAR APERTURE	>80%	>80%					
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN	mm	DWG NO	86075	SHEET 1 OF 1